Critical Temperature Dependence of Heterodyne Mixing in Superconducting Nb based Hot-Electron Bolometers

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Nb hot-electron bolometers (HEBs) with critical temperature $T_c = 5$ to 6 K have previously demonstrated good heterodyne mixing performance at THz frequencies. HEBs with a lower critical temperature are predicted to have improved performance with lower noise. We present microwave (30GHz) mixing measurements on Nb HEB mixers with $T_c$ between 1.4 and 5.3 K. The reduced $T_c$ is obtained by application of a magnetic field, or by use of a bi-layer microbridge of Nb and Au with $T_c = 1.6$ K. The mixer output noise and voltage range of low mixer noise are observed to decrease approximately linearly with reduction of $T_c$. The Nb-Au mixer has a mixer noise temperature $T_M = 50$K (DSB) with reasonable dynamic range, and thus is promising for future single pixel and array receivers for THz spectroscopy.

Heterodyne spectroscopy at terahertz frequencies is a sensitive tool for identifying molecular species important in star formation and in atmospheric chemistry processes. Hot-electron bolometer (HEB) mixers are well suited for such space-borne and ground-based astronomical applications. Unlike superconductor-insulator-superconductor (SIS) mixers, the HEB is not limited by the superconducting energy gap frequency and can operate at several terahertz. Also, diffusion-cooled HEB mixers can have very large intermediate frequency (IF) bandwidths; up to 9 GHz has been demonstrated. HEB mixers are considerably more sensitive than Schottky diode mixers, which have been used for higher frequency applications where SIS mixers are limited by the gap frequency or by RF losses.

The HEB mixer consists of a narrow, thin superconducting microbridge contacted with thick normal-metal films; see Fig. 1. The microbridge operates in the resistive state, due to application of local oscillator (LO) power and DC bias. When the RF signal is applied, the electron temperature of the microbridge (and thus the device resistance) oscillates at the IF. The IF bandwidth is determined by the inverse of the thermal relaxation time for cooling the hot electrons in the microbridge. Diffusion-cooled Nb mixers use hot-electron out-diffusion for cooling. These have demonstrated very low noise at 2.5 THz with receiver noise temperature $T_R = 1800$ K (DSB). The mixer noise temperature $T_M$ is estimated to be 350 K (DSB) for a similar device measured also at 2.5 THz. NbN phonon-cooled mixers also have good performance.

Diffusion-cooled HEB mixers consisting of a superconductor with lower critical temperature ($T_c$) are predicted to have improved performance. In optimized HEBs, thermal fluctuation noise is
Figure 1: Superconducting mixer geometry for the Nb-Au HEB, device B. The thin layer of Au above the Nb lowers the Tc of the microbridge. The Nb HEB mixer, device A, has no gold layer on top of the microbridge.

the dominant noise source neglecting quantum effects. In this case, TM is predicted to decrease linearly with Tc.\(^{11}\) Another advantage of lowering the microbridge Tc is that the required LO power decreases. The LO power for a diffusion cooled mixer is predicted to be \(P_{LO} = (4L/R)(T_c^2 - T^2)\), where \(L = 2.45 \times 10^{-8} \text{ W-\Omega/K}^2\) is the Lorenz constant, R is the electrical resistance, and T is the temperature of the normal banks. For optimum performance one has T \(<\) Tc, and thus \(P_{LO} \propto T_c^2\), being in the range 1 – 30 nW. Since output power from solid state LO sources at terahertz frequencies may be limited to \(\mu\)W, a mixer with a small required \(P_{LO}\) is desired, especially for space-borne missions and large format arrays.

A HEB mixer with reduced Tc should have improved performance, but will also be more susceptible to saturation effects that degrade TM. Such effects can be important in a THz receiver but are negligible in the microwave measurements. TM is given by TM (DSB) = \(T_{out} / 2\eta\), with \(\eta\) the conversion efficiency and \(T_{out}\) the output noise temperature. TM is minimum only over a finite voltage range but then increases due to the decrease of \(\eta\). Input saturation will occur when the absorbed RF background power is \(\sim 0.2\) \(P_{LO}\), as this reduces \(\eta\).\(^{13,14}\) Output saturation is due to RF background power downconverted to the IF which causes the voltage to deviate far from the optimum bias voltage. We characterize the voltage range for which TM remains within a factor of two of its lowest value as \(\Delta V_{opt}\). Simulations we have conducted\(^{13}\) using a discretized model for the microbridge suggest that \(\Delta V_{opt}\) will scale approximately linearly with Tc, for the simple case where the contacts to the microbridge do not perturb the superconductivity in the microbridge. This is the case for Nb devices. (In the case of Al HEBs,\(^{13,16,17}\) the voltage range is further reduced due to contact effects.) The value TM we report in the Table and Fig. 3 below is an average of TM over the 20\(\mu\)V interval of bias voltage for which this average is lowest. This definition provides a more realistic value of the expected mixer noise temperature in a receiver where averaging due to background noise or bias variations might be present.

We report here on two Nb HEBs. The first, a Nb HEB, device A, was fabricated at JPL. Similar devices were previously measured in zero magnetic field at 20, 600, 1200, and 2500 GHz.\(^{4,7,18-20}\) The dimensions are 0.081\(\mu\)m wide, 10 nm thick, and length \(L = 0.24\mu\)m. Tc in zero field is 5.3 K and is reduced to 1.4 K by applying a perpendicular magnetic field. The IF bandwidth is 1.4 GHz. The Nb-Au HEB, device B, was fabricated at Yale using double angle deposition.\(^{21}\) A thin bilayer resist is used as the lift-off stencil. A thin (10 nm) Nb film is first sputter deposited at normal incidence, followed by Au which is sputter deposited at a 45 degree angle. A thick layer of gold deposits on the contacts, mak-
ing them non-superconducting, and a thin layer of Au (about 10 nm) deposits on top of the Nb microbridge, lowering its T_c. The Nb-Au HEB is 0.20 μm wide and L = 0.48 μm. T_c in zero applied magnetic field is 1.6K. The measured IF bandwidth is 1.2 GHz, consistent with that predicted from the length and diffusion constant (determined from H_{c2}). R(T) curves are given in Fig. 2 for the Nb HEB, device A, in various magnetic fields and for the Nb-Au HEB in zero field, device B. A third device, a Nb HEB was also studied. Some of its properties were previously reported.\(^{14}\) It followed the trends of device A. However, it displayed a two-step transition in zero field, which broadened dramatically with application of a field. Its noise was about twice that of the Nb HEB, device A, which we ascribe to the unusual transition shape. We therefore do not list that device. The measurements use a liquid \(^3\)He cryostat equipped for microwave mixing measurements up to 40 GHz, at T = 0.2 K. Temperatures up to \((1/2)T_c\) could be used without significant performance degradation. For each value of T_c, the LO power and DC power is adjusted to optimize for the conversion efficiency. Microwave measurements are employed for their rapid turnaround, low background noise, and ease of calibration. Past studies of Nb devices\(^{18}\) showed reasonable correlation between such microwave measurements and THz mixing results. A summary of the device parameters is presented in the Table. T_{out} and \(\eta\) are measured at 1.4 GHz, and values listed in Table I are those extrapolated to IF = 0 using the established frequency dependence. The values of \(\bar{\eta}_M\) in the Table and Fig. 3 are at IF = 1.4 GHz.

Achieving low mixer noise is the key. The minimum \(\bar{\eta}_M\) for both devices is given as a function of T_c in Fig. 3. For device A, \(\bar{\eta}_M\) decreases linearly with the reduction of T_c, down to T_c \sim 3 K, and then increases for lower values of T_c. The decrease of \(\bar{\eta}_M\) with reduction of T_c is consistent with theoretical expectations, and results simply from the reduction of thermal fluctuations if \(\eta\) is independent of T_c. Specifically, the theory in Ref. 11 predicts T_M \sim T_c when operating with very small conversion loss and thermal fluctuations dominating all other noise processes. We observe a linear decrease in mixer noise temperature with T_c, as predicted, but with larger conversion loss (maximum conversion efficiency \(\eta = -11\ dB\)). The reason for the increase of T_M for device A for T_c < 3.3 K is the reduction of \(\eta\) for applied fields of 2 and 2.5 T, for T_c = 2.4 and 1.4 K respectively (see Table). This reduction of \(\eta\) likely results from the very small critical currents obtained at the largest fields (0.5 μA at 2.5 T), indicating non-uniform superconductivity occurs at the largest fields. This can be seen in Fig 2, where the resistive transitions at 2 and 2.5 T are seen to
Table I: Nb HEB mixer parameters. The conversion efficiency and output noise reported are IF=0 values. The $T_M$ listed is the minimum averaged over 20μV, as also in Fig. 4.

<table>
<thead>
<tr>
<th>Device</th>
<th>$T_c$ (K)</th>
<th>$H$ (T)</th>
<th>$I_c(0)$ (μA)</th>
<th>$T_{output}$ (K)</th>
<th>$\eta$ (dB)</th>
<th>$T_M$ (K)</th>
<th>$\Delta V_{opt}$ (μV)</th>
</tr>
</thead>
<tbody>
<tr>
<td>(A) Nb</td>
<td>5.3</td>
<td>0</td>
<td>100</td>
<td>26</td>
<td>-11</td>
<td>170</td>
<td>200</td>
</tr>
<tr>
<td></td>
<td>4.0</td>
<td>1.0</td>
<td>13</td>
<td>16</td>
<td>-11</td>
<td>110</td>
<td>135</td>
</tr>
<tr>
<td></td>
<td>3.3</td>
<td>1.5</td>
<td>7</td>
<td>14</td>
<td>-11</td>
<td>95</td>
<td>130</td>
</tr>
<tr>
<td></td>
<td>2.4</td>
<td>2.0</td>
<td>4</td>
<td>10</td>
<td>-15</td>
<td>180</td>
<td>90</td>
</tr>
<tr>
<td></td>
<td>1.4</td>
<td>2.5</td>
<td>0.5</td>
<td>4</td>
<td>-20</td>
<td>250</td>
<td>40</td>
</tr>
<tr>
<td>(B) Nb-Au</td>
<td>1.6</td>
<td>0</td>
<td>14</td>
<td>3</td>
<td>-12.5</td>
<td>50</td>
<td>130</td>
</tr>
</tbody>
</table>

have very large fractional temperature
widths. The small critical current at 2.5 T
of device A, 0.5 μA, can be compared with
the critical current of the Nb-Au device
which has a similar $T_c$, for which $I_c = 14$
μA. For the Nb-Au HEB, larger conver-
sion efficiency results and $T_M = 50$ K. $P_{LO}$
for the Nb-Au HEB is 2 nW compared to
0.4 nW for device A at $T_c = 1.4$ K. The
resistive transition of this Nb-Au device,
in Fig. 2, is more uniform and narrower
than device A at 2.5 T. We believe that
the relatively large critical current, low
mixer noise, $T_M = 50$ K (DSB), and rela-
tively good conversion efficiency ( $\eta = -$
12.5 dB) are characteristic of a reduced-$T_c$
device with a sharp transition. Another
Nb-Au device has similar properties to
device B.

For a practical mixer, low noise
operation must be achievable over a rea-
sonable operating range. The IV curve
and $T_M$ as a function of bias voltage are
shown for the Nb-Au, device B, in Fig. 4.
The IV curves are for $P_{LO} = 0$ and for $P_{LO} =$
2 nW, the absorbed power which gives the

![Figure 3: Mixer noise temperature from Table I for devices A (squares) and B (circle) as a function of $T_c$. $T_{bath}$= 0.2K. The dashed line is the expected linear decrease in noise temperature resulting from a decrease in thermal fluctuations.](image-url)
minimum value of $T_M$. The critical current when increasing the voltage is 14 $\mu$A; small thermal hysteresis is seen in Fig. 4. The minimum $T_M = 45$ K, occurs just above 150 $\mu$V. We show data for $T_M$ only for those voltages for which operation is completely stable. $T_M$ remains below 90 K for voltages between 150 and 280 $\mu$V, giving a voltage range $\Delta V_{\text{opt}} = 130$ $\mu$V. For $P_{\text{LO}}$ between 2 and 4 nW, the minimum $T_M$ remains below 50 K. For $P_{\text{LO}}$ between 1 and 7 nW, $T_M < 100$ K. Thus, for array applications, small variations in the optimum $P_{\text{LO}}$ for each element due to fabrication imperfections or pixel-to-pixel differences in the coupled $P_{\text{LO}}$ should not result in a significant change in the noise temperature of each pixel. We list $\Delta V_{\text{opt}}$ and other microwave parameters for both devices at all fields in the Table. We see in the Table that $\Delta V_{\text{opt}}$ decreases approximately linearly with reduction of $T_c$ for the Nb HEB.

We finally consider saturation issues. For Device A, $\Delta V_{\text{opt}}$ scales approximately linearly with $T_c$, as shown in the Table, in good agreement with numerical calculations. These predict $\Delta V_{\text{opt}} \sim 100$ $\mu$V for a HEB with a uniform $T_c = 1.6$K along the length of the bridge. With the experimental value $\Delta V_{\text{opt}} \sim 130$ $\mu$V, we estimate for the Nb-Au HEB the level of IF power which would begin to produce output saturation as approximately 40 pW at the IF. This corresponds to a background noise temperature $T_{\text{back}} = 13,000$ K with an IF bandwidth of 2 GHz, assuming $\eta = -12.5$ dB (total RF bandwidth of 4 GHz due to both sidebands). Such a large level of background noise is not expected in typical applications. Input saturation would result if the coupled broadband background noise power is comparable to $P_{\text{LO}} = 2$ nW. For receivers with 200 GHz RF bandwidth, the incident background power is 0.5 nW for $T_{\text{back}} = 200$ K. The Nb-Au HEB should thus show no significant saturation effects. Overall, the Nb-Au HEB shows better performance than a Nb HEB in a magnetic field. In applications where the instantaneous RF bandwidth is very large ($\geq 0.5$ THz), Nb-Au devices with slightly higher $T_c$, for increased $P_{\text{LO}}$, can be used to avoid input saturation. Such devices can be produced with a thinner Au layer. Thus, the Nb-Au HEB looks very promising for THz applications with low mixer noise and very small required LO power, and should provide sufficient dynamic range for the anticipated applications.

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It is unclear if superconducting films are available to produce phonon-cooled mixers with lower $T_{\text{c}}$ but also having adequate IF bandwidth. If such materials can be found, our arguments for reduction of $T_{\text{c}}$ would also apply to these phonon-cooled devices.

$T_{\text{c}}^0$ is larger than at $30 \text{ GHz}$. 

In contrast to these results for Nb and Nb-Au, we find for Al HEBs that output saturation at the IF is a significant issue. A large fraction of the microbridge (up to 50%) is made non-superconducting even at $T = 0$ by the normal contacts, so that $\Delta V_{\text{sat}} < 10 \mu V$ for a typical Al HEB. This is consistent with our simulations.